

<b>Notice of References Cited</b>	Application/Control No. 10/801,475	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Monica Lewis	Art Unit 2822	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2005/0035457	02-2005	Tomita et al.	257/758
	B	US-6,225,697	05-2001	Iguchi, Manabu	257/758
	C	US-2004/0195670	10-2004	Landis, Howard S.	257/700
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Peter Van Zant, Microchip Fabrication, 2000, McGraw-Hill, Pages 398-401.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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